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# TEMPEST USERS' GUIDE Version 4.0

by

Alfred Wong

Memorandum No. UCB/ERL M95/14

14 March 1995

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# **ELECTRONICS RESEARCH LABORATORY**

College of Engineering University of California, Berkeley 94720

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#### **Contributors**

This is the fourth release of TEMPEST. The previous release dates were:

ver1.0 July 23, 1991.

ver2.0 December 31, 1992.

ver3.0 July 14, 1994.

The following people have contributed to TEMPEST:

Original Authors:

John Gamelin(ver1.0) Roberto Guerrieri(ver1.0) Karim Tadros(ver1.0) Alfred Wong(ver2.0, 3.0, and 4.0)

Contributors to earlier releases:

Takeshi Doi(ver1.0) Eric Hall(Manual Format)

TEMPEST is developed at the University of California at Berkeley by a student research group on process modeling and technology with Professor Andrew R. Neureuther. The development of TEMPEST has been primarily supported by a SRC/SEMATECH grant, as well as computer time from the Thinking Machines Corporation and the National Center for Supercomputing Applications (NCSA).

An initial \*LISP version for the CM-2 architecture was written by John Gamelin and extended and tested by Karim Tadros. Alfred Wong converted the code to C\*, added TM polarization, off-axis illumination, and post process image synthesis in version 2.0. In version 3.0, he added three-dimensional analysis capabilities on the CM-5 and linked TEMPEST with SPLAT. Version 4.0 has similar capabilities with version 3.0, except that version 4.0 is written in C and can be executed on work stations and personal computers.

To encourage open exchange of information, TEMPEST and its supporting utilities are available on an as-is basis for a small handling fee. However, there is usually no assistance available for implementing the program or in training users. Although a prompt response cannot be promised, feedback on the program and comments are welcome. Please mail to:

Professor Andrew R. Neureuther EECS Department 510 Cory Hall University of California, Berkeley Berkeley, CA 94720 U. S. A. (510)642-4590 neureuth@eecs.berkeley.edu

# TEMPEST version 4.0

# Alfred Wong

# **Electronics Research Laboratory**

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# 1.0 Introduction

# 1.1 Overview

The acronym TEMPEST<sup>3</sup> stands for "Time-domain Electromagnetic Massively Parallel Evaluation of Scattering from Topography." The computer program solves Maxwell's equations using a time-domain finite-difference algorithm, where the electric and magnetic field nodes are spatially and temporally staggered over a three-dimensional topography of interest. Version 3.0 takes advantage of the inherent parallel nature of electromagnetic wave propagation and is implemented on the computer architecture connection machine 5 (CM-5)<sup>8</sup>. Due to the limited availability of the CM-5, version 4.0 is implemented on any single-processor computer architecture such as a work station or even a person computer. The simulation domain may represent periodic or symmetric topography. The algorithm is capable of simulating problems such as scattering from asymmetrical alignment marks, transmission through phase-shifting masks, effects of line-edge profiles in metrology as well as dynamic bleaching of photoresist over arbitrary non-planar, inhomogeneous wafer topographies.

Illumination is assumed to be monochromatic, with the electric field linearly polarized in any user-specified direction. The incident angle can take on discrete values depending on the illumination wavelength and the dimension of the simulation domain. Illumination is assumed to be coherent and can consist of any intensity profile such as that calculated from SPLAT<sup>9</sup>. The steady-state electric fields as well as the magnitudes and phases of diffraction harmonics are found. The photosensitizer concentration is calculated if a layer of photoresist is present. The matrix containing this concentration information can be used in

other simulation programs such as SAMPLE<sup>4</sup> for simulation of resist development. Information on the diffraction harmonics is used to form optical image profiles in SPLAT<sup>9</sup>. Imaging can be done on the scattered fields (for example, reflected light from alignment marks) or the transmitted fields (for example, light passing through a phase-shift mask).

TEMPEST parses topography information from an input file which can be checked for correctness. The input geometry is then simulated until the electromagnetic field reaches steady-state or, in the case of non-convergence, the simulation domain is excited for a user chosen number of wave cycles. Information on the simulation parameters as well as the diffraction harmonics are written to an output file. Optical image profiles based on the diffraction harmonics can be generated by the simulation program SPLAT<sup>9</sup>. Line plots, contour plots, and/or density plots of the field amplitude, steady-state field, transient field, refractive index and photo active compound (PAC) concentration in any region of the simulation domain can be generated using the plotting package PLOTMTV.

#### 1.2 New in Version 4.0

Version 4.0 of the program TEMPEST has several extensions from the previous version (version 3.0). Three-dimensional problems can be analyzed on a work station instead of a supercomputer. Furthermore, the number of simulation nodes in the height dimension (the z-direction) is no longer restricted to powers of 2. This represents a savings in the amount of memory needed. Checking of the input file is no longer done by the auxiliary routine CHECK. Instead, invoking TEMPEST with only the input file name checks the input file for correctness.

Besides the main electromagnetic fields solver program, TEMPEST version 4.0 includes several auxiliary programs. The programs AMPHA1D and AMPHA2D allow the user to calculate the amplitude and phase of any electromagnetic field component along any line or plane. TOTAL1D and TOTAL2D are used to calculate the total electric or magnetic field along a line and a plane respectively. REDUCE2D is used to reduce data volume and to ease output data processing.

#### 1.3 Applications Information

TEMPEST is capable of simulating a number of optical phenomena occurring in photolithography and optical metrology applications. These include bleaching of photoresist over arbitrary topography (e.g., reflective notching), dark-field and bright-field imaging of wafer features (e.g., alignment marks and line structures), generation of image profiles through masks (e.g., reduction phase-shift mask), and calculation of the electric and magnetic fields at all

points in the three-dimensional simulation domain at any instant in time. Several studies involving these topics have already been performed, and the user is encouraged to refer to these publications<sup>2,3,6,7,11,12,13,14</sup>. In general, TEMPEST simulations can be placed into two categories:

- 1. Lithography which involves dynamic changes during exposure, and
- 2. Imaging and scattering analysis.

These categories are distinguished primarily by the desired output. For lithography the desired output is the final PAC concentration. For imaging/scattering purposes the primary output desired are the electromagnetic fields and the diffraction harmonics. These data are used by the program SPLAT to form the bright-field or dark-field images. Details of the image synthesis procedure are described in Section 4.3.1. The other desirable output for an imaging/scattering analysis is the field values in the simulation domain. Line plots, contour plots, surface plots and/or density plots of the transient field and the steady-state field, the PAC concentration and the refractive index can be generated. Generation of these plots are described in Section 4.1.5.

#### 1.4 Source Code Information

TEMPEST ver4.0 is written in the C programming language. The source code is distributed into twelve text files. Six header files are also included. The header files are:

defn.hconstant definitionsglobal.hglobal variable definitionsheader.hheader files to be included

lib.h libraries to include

routn.h subroutines used in the program ver.h subroutines used in the program version and release date information

The files which contain the source code are:

bc.c boundary conditions bulk.c interior updating equations

de.c computes the diffraction harmonics in.c reads information from the input file

init.c initialization of variables iterate.c fields computation by iteration

loop.c calls different loops according to the model

main.c program control math.c mathematical functions misc.c miscellaneous functions

out.c prints simulation results to output files

resist.c models photoresist bleaching

# 1.5 About this Manual

Section 1.0	Introduction A general overview of TEMPEST is provided.
Section 2.0	Installation This section discusses how the simulation program TEMPEST and other auxiliary programs are compiled and installed.
Section 3.0	Tutorial Two tutorial examples to let the user become familiar with the commands and procedures of running TEMPEST are given
Section 4.0	Detail Command Descriptions  Detail descriptions of the commands and input file keywords are presented in this section.
Section 5.0	Useful Hints Some useful hints for running TEMPEST are given.
Appendix A	Summary of Commands Important commands are briefly listed.

The conventions used throughout this users' guide are as follows:

- Words which are in ALL CAPITAL LETTERS represent programs or shell scripts.
- Words in **bold** letters represent commands to be typed exactly as it appears on the users' guide.
- Words in *italics* represent commands or arguments which can take on different values or character strings.
- Words inside [square brackets] are options to commands which may be omitted.
- Words in the Courier font represent characters in a file or output from programs.
- The string "ws%" represents the unix prompt on a workstation.

#### 2.0 Installation

#### 2.1 Resource Requirements

The computing environment of the user should:

- run unix C-shell
- have a C compiler
- have a postscript printer
- have at least 20 mega bytes of disk space available to hold the data files

In addition, it is useful to have X11 windows to display plots of the data by the plotting program PLOTMTV.

#### 2.2 Installation

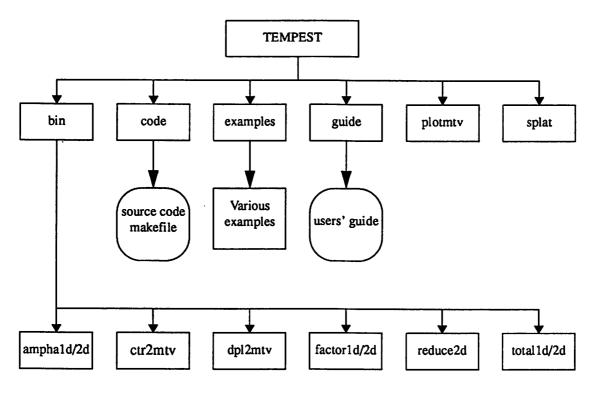
This software package consists of the main program TEMPEST as well as other supporting routines to be run on the user's workstation. All the programs except for SPLAT are written in the programming language C.

- 1. TEMPEST (Program for electromagnetic simulation.)
- 2. AMPHA1D and AMPHA2D (Programs which calculate the amplitudes and phases of the electromagnetic fields from the instantaneous field values.)
- 3. CTR2MTV and DPL2MTV (Programs which convert CONTOUR and DRAWPLOT data format to PLOTMTV data format.)
- 4. FACTOR1D and FACTOR2D (Programs which scale the axes of plot files.)
- 5. REDUCE2D (Program for reducing data file size.)
- 6. TOTAL1D and TOTAL2D (Programs which calculates the total electric or magnetic field from the values of the x, y, and z components.)
- 7. PLOTMTV (Program for displaying data files.)
- 8. SPLAT (Program written in Fortran for calculating aerial images.)

To install TEMPEST, please move to a directory (say \$HOME/bin) where TEMPEST should reside. Then insert the tape into the tape drive, and type the following command:

ws% tar xv

After tape reading is completed, which takes about 5 minutes, a TEMPEST directory is created in the \$HOME/bin directory. The programs are organized as follows:



# 2.3 Compilation

# 2.3.1 TEMPEST

To compile TEMPEST, follow the steps:

- 1. ws% cd \$HOME/bin/TEMPEST/code
- 2. cm% make

# 2.3.2 SPLAT

The program SPLAT can be compiled using make:

- 1. ws% cd \$HOME/bin/splat
- 2. ws% make

# 2.3.3 PLOTMTV

Compilation of plotmtv uses the utility xmkmf. Please following the instructions in the file \$HOME/bin/plotmtv/README.INSTALL

#### Installation

#### 2.3.4 OTHER ROUTINES

The other routines such as AMPHA1D, AMPHA2D, CHECK, FACTOR1D, FACTOR2D, IMAGE2D, and REDUCE2D can be compiled as follows:

- 1. ws% cd \$HOME/bin/TEMPEST/bin
- 2. ws% makeall

# 2.4 Testing

When all the programs are compiled, they can be moved to a directory which is contained in the unix variable \$PATH, for example, \$HOME/bin.

To test if the programs are installed properly and the computing environment is proper, please do the following:

- 1. ws% cd \$HOME/bin/tempest/examples
- 2. ws% run.csh

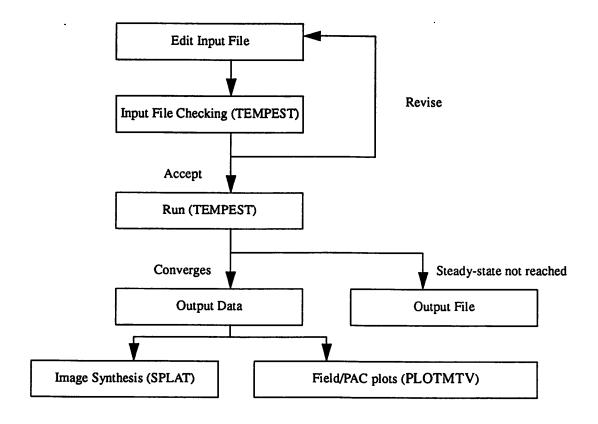
Several examples are run which illustrate the normal workings of TEMPEST.

3. Follow the examples in Section 3.0 to make sure that all the routines are functioning properly.

#### 3.0 Tutorial

#### 3.1 Overview

The basic steps in running TEMPEST simulation are shown as follows:



A simulation can take anywhere from a few minutes to several hours depending on the size of the problem. The request of large data files (such as a contour plot of a large area) also requires more simulation time.

# 3.2 Input File to TEMPEST

The input file to TEMPEST contains five types of specifications:

- 1. simulation domain
- 2. illumination
- 3. topography
- 4. analysis (numerical parameters)
- 5. data (output specifications)

The input file to TEMPEST can be given any name and the entries in the input file can occur in random order. (The only exception is that the definition of wavelength must precede the definition of any block property.) The input file to TEMPEST consists of a list of keywords; each keyword may be followed by numbers, words, or other keywords. A detail description of the keywords is found in Section 4.1. Comments can be included in the input file by including the string "/\*" before the comment and the string "\*/" after the comment.

As a first example, transmission through a 1X contact hole is studied. The input file is located in the directory \$HOME/bin/TEMPEST/examples/hole and is named *hole.in*. The dimension of the simulation domain is 1.0  $\mu$ m by 1.0  $\mu$ m by 0.25  $\mu$ m. (The actual simulated volume is 0.5  $\mu$ m by 0.5  $\mu$ m by 0.25  $\mu$ m via the use of symmetry.) The chrome mask has a glass substrate with a layer of 80 nm thick chrome. The square opening on the chrome has a width of 0.25  $\mu$ m on each side. Illumination is assumed to be normally incident at 248 nm, with the electric field linearly polarized in the x-direction. In this study, the transmitted diffraction harmonics are requested to study the transmission characteristics of the mask. In addition to the diffraction harmonics, the transmitted electric field in the x-direction is also requested.

The input file hole.ing is shown as follows:

```
/*
input file name: hole.in
*/
/*
The structure is symmetric with respect to both the x- and y-axes.
sym_model 2
/*
The simulation window is 0.5 by 0.5 by 0.25 micron with 65 simulation nodes
in the x- and y-directions and 32 nodes in the z-direction.
*/
x node 65
y node 65
z node 32
x \dim 0.5
y dim 0.5
z dim 0.25
periodic
wavelength 0.248
intensity 1.0
/*
The transmitted diffraction harmonics are calculated and the results are
```

```
stored in the file hole.hrm. hole.spl is a SPLAT input file.
transmitted hole.spl hole.hrm
na 0.5
sigma 0.5
focus 0.0
mag 1
err_tol 0.02
Block 1 is glass with index of (1.5, j0.0).
*/
block 1
figure rectangle
0.0 0.5 0.0 0.5 0.0 0.25
index 1.5 0.0
end_block
Block 2 is air with index of (1.0, j0.0).
*/
block 2
figure rectangle
0.0 0.5 0.0 0.5 0.0 0.10
index 1.0 0.0
end_block
Block 3 is chromium with index of (2.5, j2.0).
*/
block 3
figure rectangle
0.0 0.5 0.0 0.5 0.10 0.18
index 2.5 2.0
end block
/*
Block 4 represents the contact hole opening (air) with index of 1.0.
block 4
figure rectangle
0.375 0.5 0.375 0.5 0.10 0.18
index 1.0 0.0
end_block
/*
The instantaneous electric field in the x-direction of a plane just
underneath the opening is requested at two instants of the wave cycle.
*/
```

```
plot steady xyplane 0.00 e x node 0 63 0 63 15 hole.xyp.000 plot steady xyplane 0.25 e x node 0 63 0 63 15 hole.xyp.250
```

# 3.3 Checking the Input File

To check whether the input file is correct, one can execute TEMPEST with the input file name as the only argument:

ws% tempest hole.in

With this command, the following is displayed, indicating that there is no error in the input file *hole.in*:

```
T E M P E S T
ver4.0
February 7, 1995
Starting TEMPEST...
Reading input file [hole.in]...
Done reading input file [hole.in].
There is no error in the file.
```

# 3.4 Running Simulations

With no error messages, the input file is in the correct format and the electromagnetic field solver TEMPEST can be run. To execute the program TEMPEST, the user must supply two arguments: the first being the name of the input file, and the second is the name of the output file to which information concerning the simulation is to be written.

The amount of memory needed to run the program is proportional to the number of simulation nodes in the domain, i.e., the product of the number of nodes in the x-, y-, and z-directions. As a rule of thumb, a domain with 128k nodes (64 by 64 by 32) requires about 16MBytes of memory.

To run TEMPEST, type ws% tempest hole.in hole.out

```
T E M P E S T
ver4.0
February 7, 1995
Starting TEMPEST...
Reading input file [hole.in]...
Done reading input file [hole.in].
```

Initializing parameters and variables...

#### Warning:

Minimum number of simulation nodes per wavelength for the topography is 12.70, fewer than 15. Simulation result may be inaccurate.

Done initializing parameters and variables.

Start iteration ...

Period #4:

1st try: 100.00% converged.

Period #5:

1st try: 100.00% converged. 2nd try: 100.00% converged.

Period #6:

1st try: 100.00% converged. 2nd try: 100.00% converged. 3rd try: 100.00% converged. Converges after 6 periods.

Done iteration.

Writing plot file [hole.xyp.000]... Done writing.

Writing plot file [hole.xyp.250]... Done writing.

Calculating diffraction efficiencies...

Done calculating diffraction efficiencies.

Writing to output file [hole.out]...
Done writing.

Program executed successfully.

Five files are generated for this simulation:

- 1. hole.out (output file which contains information on the simulation run)
- 2. hole.hrm (harmonic file which contains information on the diffraction harmonics)
- 3. hole.spl (SPLAT input file used for generating the image)
- 4. hole.xyp.000 and hole.xyp.250 (electric field plots across an xy-plane in PLOTMTV format)

#### 3.5 Output Data

# 3.5.1 Output File

The output file of TEMPEST contains information on the simulation parameters, such as the spatial and temporal discretization values, and recapitulates some of the input parameters. If steady-state is reached and the user requested so, information on the diffraction harmonics is written to the output file and harmonic file as well. This information can be used to synthesize the optical image profile of the structure using the simulation program SPLAT.

The output file generated, *hole.out*, is shown below. It summarizes the topography information and numerical parameters and contains information on the diffraction harmonics.

TEMPEST

ver4.0 February 7, 1995

University of California, Berkeley

Miscellaneous Information:

Input file name: hole.in
Output file name: hole.out
SPLAT input file name: hole.spl
Harmonic file name: hole.hrm

There are 2 plot files:

Steady-state field hole.xyp.000
 Steady-state field hole.xyp.250

#### Process Parameters:

Free space wavelength: +2.4800e-01 um

Incident theta: +0.0000e+00
Incident phi: +0.0000e+00

Refl abs angle: +0.0000e+00 +9.5166e+00 Tran abs angle: +0.0000e+00 +1.4359e+01

Incident relative (Ex Ey): +1.0000e+00 +0.0000e+00

Incident cosine (Ex Ey Ez): +1.0000e+00 +0.0000e+00 +0.0000e+00 Incident cosine (Hx Hy Hz): +0.0000e+00 -1.0000e+00 -0.0000e+00 Incident cosine (Kx Ky Kz): +0.0000e+00 +0.0000e+00 -1.0000e+00

Illumination intensity: +1.0000e+00 mW/cm2

Mask file name: None

```
Topography:
The structure is assumed to be periodic.
Symmetry: wrt x- and y-axes
x dimension: 5.0000e-01 um
y dimension: 5.0000e-01 um
z dimension: 2.5000e-01 um
Index at north boundary: 1.5000e+00 0.0000e+00
Index at south boundary: 1.0000e+00 0.0000e+00
Number of building blocks: 4
Block 1:
 index (+1.5000e+00 +0.0000e+00)
 eps (+2.2500e+00 +0.0000e+00)
 eta (+2.5115e+02 +0.0000e+00)
 cond (+0.0000e+00)
 fig rectangle
 xl xh 0.0000e+00 5.0000e-01
 yl yh 0.0000e+00 5.0000e-01
 zl zh 0.0000e+00 2.5000e-01
Block 2:
 index (+1.0000e+00 +0.0000e+00)
 eps (+1.0000e+00 +0.0000e+00)
 eta (+3.7673e+02 +0.0000e+00)
 cond (+0.0000e+00)
 fig rectangle
 xl xh 0.0000e+00 5.0000e-01
 yl yh 0.0000e+00 5.0000e-01
 zl zh 0.0000e+00 1.0000e-01
Block 3:
 index (+2.5000e+00 +2.0000e+00)
 eps (+2.2500e+00 +1.0000e+01)
 eta (+9.1885e+01 +7.3508e+01)
 cond (+6.7251e+05)
 fig rectangle
 xl xh 0.0000e+00 5.0000e-01
 yl yh 0.0000e+00 5.0000e-01
 zl zh 1.0000e-01 1.8000e-01
Block 4:
 index (+1.0000e+00 +0.0000e+00)
eps (+1.0000e+00 +0.0000e+00)
eta (+3.7673e+02 +0.0000e+00)
cond (+0.0000e+00)
 fig rectangle
```

xl xh 3.7500e-01 5.0000e-01

```
yl yh 3.7500e-01 5.0000e-01
 zl zh 1.0000e-01 1.8000e-01
Computational parameters:
Distance between nodes (dx): 7.8125e-03 um
Simulation grid: 65 \times 65 \times 32
Minimum nodes per wavelength: 12.70
Time increment (dt): 1.4772e-17 second
Iterations per period (wave cycle): 56
Bulk model: 0
BC model: 4
Convergence information:
Wave cycles before convergence check: 3
Maximum iteration wave cycles: 60
Error tolerance: 2.00%
Number of periods for convergence: 6
Transmitted diffraction efficiencies:
Number of diffracted orders: 9 9
 Real Imag
order[ +0 ][ -3 ]: +2.490130e-02 +1.142663e-02
 +0.000000e+00 +0.000000e+00
 +0.000000e+00 +0.000000e+00
 -1.546077e-02 -7.116144e-03
order[ +0 ][ -2 ]: -3.704284e-02 +5.493885e-03
 +0.000000e+00 +0.000000e+00
 +0.000000e+00 +0.000000e+00
 +3.124916e-02 -4.320902e-03
order[ +0 ][ -1 ]: +4.080810e-02 -1.982616e-02
 +0.000000e+00 +0.000000e+00
 +0.000000e+00 +0.000000e+00
 -3.827879e-02 +1.834613e-02
order[ +0 ][ +0 ]: -3.222521e-02 +2.422668e-02
 +0.000000e+00 +0.000000e+00
 +0.000000e+00 +0.000000e+00
 +3.181921e-02 -2.402239e-02
order[ +0 ][ +1 ]: +3.978613e-02 -2.180464e-02
 +0.000000e+00 +0.000000e+00
 +0.000000e+00 +0.000000e+00
 -3.733248e-02 +2.020228e-02
order[ +0 ][ +2 ]: -3.632597e-02 +9.098263e-03
```

#### **Tutorial**

```
+0.000000e+00 +0.000000e+00
+0.000000e+00 +0.000000e+00
+3.067517e-02 -7.363049e-03
order[ +0 ][ +3 ]: +2.630842e-02 +7.649179e-03
+0.000000e+00 +0.000000e+00
+0.000000e+00 +0.000000e+00
-1.633759e-02 -4.770555e-03
...
Transmitted energy: 2.95%
Total refl and tran energy: 19.72%
```

#### 3.5.2 Image Synthesis

Based on the information of the diffraction harmonics contained in the output file, the optical image profile of the simulated structure can be synthesized given the characteristics of the optical system, including the numerical aperture (NA), partial coherence factor, and the magnification factor. Since TEMPEST assumes coherent illumination, partial coherence is modeled by Hopkins' approach<sup>1</sup>. Two assumptions are made:

- 1. The magnitudes of the diffraction efficiencies are independent of the angle of illumination.
- 2. The illumination energy is distributed evenly over the illumination cone.

With these assumptions, the intensity at every point in space can be calculated by evaluating the transmission cross coefficients<sup>1</sup>. This approach can be used to model bright-field or dark-field optical systems, arbitrary lens aberrations as well as defocus effects.

For the example structure, assume that the optical system is 1X and has an NA of 0.5 and a partial coherence factor of 0.5. The optical signal produced by the chrome mask can be synthesize by the command

```
ws% splat < hole.spl
```

where *hole.spl* is generated by TEMPEST. The command splat is described in detail in Section 4.3.1.

With the above command, two data files are generated: *hole.spl.ild* in the DRAWPLOT format and *hole.spl.i2d* in the CONTOUR format. To convert these files into the PLOTMTV format, use DPL2MTV and CTR2MTV:

```
ws% dpl2mtv hole.spl.i1d hole.mtv1d
ws% ctr2mtv hole.spl.i2d hole.mtv2d
```

Since the intensity date calculated by SPLAT have negative values when the transmitted image is requested, the PLOTMTV data files must be modified by

multiplying the intensity value by -1. This is accomplished by the routines FACTOR1D and FACTOR2D:

ws% factor1d hole.mtvld hole.facld y -1 ws% factor2d hole.mtvi2d hole.fac2d -1

The files can then be plotted with PLOTMTV. For example, the image in Figure 1 can be generated with:

# ws% plotmtv hole.fac2d

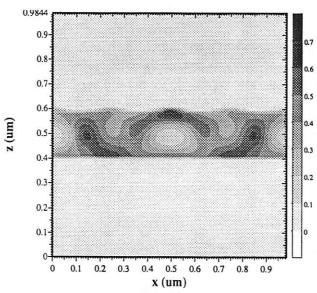


Figure 1 The optical signal created by a 1  $\mu$ m by 1  $\mu$ m square opening on a 1X chromium mask. The optical system has an NA of 0.5 and a partial coherence factor of 0.5.

# 3.5.3 Field and PAC plots

The data files generated by TEMPEST are all in the PLOTMTV format. To plot the data files, simply issue the command

ws% plotmtv file name

For example, to display the data file hole.xyp.000, type

ws% plotmtv hole.xyp.000

and the picture in Figure 2 is displayed on the screen.

# 4.0 Detail Command Descriptions

# 4.1 Input File Keywords

The input file to TEMPEST contains five types of specifications:

- 1. simulation domain
- 2. illumination
- 3. topography
- 4. analysis (numerical parameters)
- 5. data (output specifications)

The input file to TEMPEST can be given any name and the entries in the input file can occur in random order. (The only exception is the definition of wavelength must precede the definition of any block property.) Comments can be included in the input file by including the string "/\*" before the comment and the string "\*/" after the comment. Further, this version (as does the previous version) of TEMPEST performs error checking of the input file and will be able to detect most input errors. The input file to TEMPEST consists of a list of keywords. Each keyword may be followed by numbers, words, or other keywords. The following is a description of the keywords:

#### 4.1.1 Domain

### x\_node x\_simulation\_nodes

x\_simulation\_nodes is a number specifying the number of simulation nodes in the x-dimension of the simulation domain. If no\_de is specified, then there is no restriction on the value of x\_simulation\_nodes. Otherwise, x simulation\_nodes must be a positive number which is a power of 2 if

 $x\_simulation\_nodes$  must be a positive number which is a power of 2 if  $sym\_model$  is 0. If  $sym\_model$  is 1 or 2,  $x\_simulation\_nodes$  must be a positive number which is a power of 2 plus 1 ( $2^n+1$ ). Typically, at least 15 simulation nodes per wavelength are necessary in the optically densest material to give accurate simulation results.

#### y node y simulation nodes

y\_simulation\_nodes is a number specifying the number of simulation nodes in the y-direction of the simulation domain. If no\_de is specified, then there is no restriction on the value of y\_simulation\_nodes. Otherwise,

 $y\_simulation\_nodes$  must be a positive number which is a power of 2 if  $sym\_model$  is 0 or 1. If  $sym\_model$  is 2,  $y\_simulation\_nodes$  must be a positive number which is a power of 2 plus 1 ( $2^n+1$ ).

#### z\_node z simulation nodes

z\_simulation\_nodes is a number specifying the number of simulation nodes in the z-direction of the simulation domain. There is no restriction on the

value of z\_simulation\_nodes. In terms of memory usage, a 64 by 64 by 32 nodes simulation domain needs about 16 MBytes of memory. The maximum number of simulation nodes is limited by the available memory of the computing environment.

#### x\_dim x\_length

x\_length is the x-dimension of the simulation domain in micro-meter.

#### y\_dim y\_length

y\_length is the y-dimension of the simulation domain in micro-meter.

# z\_dim z length

 $z_{length}$  is the z-dimension of the simulation domain in micro-meter. A constraint is placed on the maximum values of  $x_{length}$ ,  $y_{length}$ , and  $z_{length}$  in order to maintain a sufficiently high grid density for simulation accuracy and algorithm stability. Typically, at least 15 simulation nodes per wavelength are necessary in the optically densest material to give accurate simulation results. Therefore, the maximum values of  $x_{length}$ ,  $y_{length}$ , and  $z_{length}$  are limited by the number of nodes which is in turn limited by the physical resources of the user's computing environment.

#### periodic

keyword **periodic** specifies that the structure under study is a periodic structure. This is the default.

#### isolated

keyword isolated specifies that the structure under study is an isolated structure. The default structure type is periodic. Presently, isolated structures are not supported.

#### 1symmetry

if the structure possesses symmetry in one of the dimensions, specify **1symmetry**. The structure is then assumed to be symmetric in the x-direction (with respect to the y-axis). When **1symmetry** is specified, the argument of rel\_ex0 must be 1.0 (the default) or 0.0.

#### 2symmetry

For a structure which is symmetric with respect to both the x- and y-axes, specify 2symmetry. Similar to the case in 1symmetry, the argument of rel ex0 must be 1.0 (the default) or 0.0.

#### sym\_model model number

model\_number is 0 if there is no symmetry in the structure. model\_number is 1 if the structure is symmetric with respect to the x-axis (same as 1symmetry). For a structure which is symmetric with respect to both the x-and y-axes, model\_number is 2 (same as 2symmetry). The default value of model\_number is 0.

#### 4.1.2 Illumination

#### wavelength lambda

lambda is the free space wavelength of the incident illumination in micrometer. TEMPEST assumes monochromatic illumination. wavelength must be defined before definition of any block property.

#### intensity value

value is the intensity of the incident illumination in milli-Watt per centimeter squared. The incident field amplitude is determined from value, which is given by the expression  $E = \sqrt{2 \times \text{value} \times 10 \times \text{s}}$  (x)  $\times \eta$  where s(x) represents intensity modulation specified by the keyword mask. If there is no intensity modulation, s(x) = 1. The factor 10 is a unit-conversion factor.

inc\_the theta\_inc

# inc\_phi phi\_inc

The illumination direction is specified by the angles theta\_inc and phi\_inc. The direction of propagation of the incident radiation makes an angle of theta\_inc (in degrees) with the z-axis and an angle of phi\_inc (in degrees) with the x-axis. The default value for theta\_inc and phi\_inc is zero. In the current version, oblique incidence works only for periodic structures. Further, only discrete values of theta\_inc and phi\_inc are allowed, corresponding to integral multiples of 360° phase difference between the east-west and north-south boundaries.

### rel ex0 ex0

The relative amount of x-polarized electric field is exO, which is a value between 0 and 1. From exO, the relative amount of y-polarized electric field is calculated by  $eyO = \sqrt{1 - exO^2}$ . Together with  $theta_inc$  ( $\theta$ ) and  $phi_inc$  ( $\phi$ ), the directional cosines of E, H, and  $\kappa$  are calculated to be  $(exO\cos\phi + eyO\sin\phi, -exO\sin\phi + eyO\cos\phi, eyO\sin\theta)$ ,  $(-exO\cos\theta\sin\phi + eyO\cos\phi, -exO\cos\theta\cos\phi - eyO\sin\phi, -exO\sin\theta)$ , and  $(\sin\theta\sin\phi, \sin\theta\cos\phi, -\cos\theta)$  respectively.

inc\_abs1 incl

#### inc abs2 inc2

The second order absorbing boundary condition implemented allows the user to choose two angles at which the boundary condition absorbs perfectly. On the top boundary, these angles are specified by *incl* and *inc2* (in degrees). They are measured from the z-axis.

tra abs1 tral

#### tra abs2 tra2

Similar to *inc1* and *inc2*, *tra1* and *tra2* are the perfect absorption angles at the bottom boundary in degrees measured from the z-axis.

#### mask mask file

keyword mask specifies that the incident intensity is not uniform across the simulation domain. The intensity modulation information is contained in

mask\_file, a file in the PLOTMTV format which may be generated from SPLAT and CTR2MTV.

# 4.1.3 Topography

# block block\_num figure block figure block info end block

keyword block is one of two ways to specify properties of the simulation structure. block specifies that the properties of block block\_num are contained in block\_info. TEMPEST continues parsing properties for block block\_num until the keyword end\_block is encountered. The illumination wavelength must be defined before any block information can be given. If two blocks overlap in volume, then the material properties of the overlapped volume is determined by the latter defined block. The maximum number of blocks allowed is 1024.

figure signifies that the next word defines the shape of the current block. block\_figure can be one of the following:

#### rectangle xl xh yl yh zl zh

rectangle specifies that the current block is a rectangular box bounded in the x-direction by [xl, xh], in the y-direction by [yl, yh], and in the z-direction by [zl, zh].

#### sphere radius xcenter ycenter zcenter

sphere specifies that the current block is a sphere with radius radius centered at (xcenter, ycenter, zcenter).

#### xcylinder radius xl xh ycenter zcenter

**xcylinder** specifies that the current block is a circular cylinder oriented along the x-direction from xl to xh with radius radius. The circular cross-section on the yz-plane is centered at (ycenter, zcenter).

# ycylinder radius yl yh zcenter xcenter

ycylinder specifies that the current block is a circular cylinder oriented along the y-direction from yl to yh with radius radius. The circular cross-section on the zx-plane is centered at (zcenter, xcenter).

#### zcylinder radius zl zh xcenter ycenter

zcylinder specifies that the current block is a circular cylinder oriented along the z-direction from zl to zh with radius radius. The circular cross-section on the xy-plane is centered at (xcenter, ycenter).

#### xwedge xl xh yl zl y2 z2 y3 z3

**xwedge** specifies that the current block is a wedge with a triangular interface with the yz-plane defined by the coordinates (y1, z1), (y2, z2), and (y3, z3). The wedge is oriented along the x-direction from xl to xh.

# ywedge yl yh zl xl z2 x2 z3 x3

ywedge specifies that the current block is a wedge with a triangular interface with the zx-plane defined by the coordinates (z1, x1), (z2, x2), and (z3, x3). The wedge is oriented along the y-direction from yl to yh.

#### zwedge zl zh xl yl x2 y2 x3 y3

**zwedge** specifies that the current block is a wedge with a triangular interface with the xy-plane defined by the coordinates (xl, yl), (x2, y2), and (x3, y3). The wedge is oriented along the y-direction from zl to zh.

block\_info consists of a list of numbers and words, which may be:
index real index imag index

real\_index and imag\_index are respectively the real and imaginary parts of the refractive index of the current block of material. imag\_index must be either greater than zero (representing dielectric loss) or equal to zero (lossless dielectric). If the value of imag\_index is greater than that of real\_index, "dispersive" must be specified in the input file.

# eps real\_eps imag\_eps

real\_eps and imag\_eps are respectively the real and imaginary parts of the relative permittivity of the current block of material. imag\_eps must be greater than zero (representing dielectric loss) or equal to zero (lossless dielectric). For each block, either index or eps, but not both, should be specified.

#### cond conductivity

if the current block is a metal, the properties can be specified by its conductivity conductivity. If only cond is specified, the real part of the relative permittivity is assumed to be 1.0 and the imaginary part is calculated from the value of conductivity. If both cond and eps are specified, the real part of the dielectric constant is given by real\_eps, and the imaginary part is given by the sum of contributions from imag\_eps and conductivity. For any block, index and cond cannot both be specified.

#### resist conc a b c dose step

resist specifies that the current block has dynamic change with respect to exposure. conc is the initial PAC value of the photoresist block. a is Dill's bleachable absorption coefficient of the photoresist in per micro-meter. b is Dill's unbleachable absorption coefficient of the photoresist in per micro-meter. c is the bleach rate of the photoresist model proposed by Dill in centi-meter squared per milli-Joule. dose is the total exposure energy of the photoresist in milli-Joule per centi-meter squared. The total dose is divided into step

number of smaller doses, the sum of which equals the total *dose*. For each dose step, the steady-state electric field is computed and the bleaching of the photoresist block is modeled using Dill's ABC parameters.

#### read\_index index file

Another way to specify the properties of the simulation structure is by the keyword read\_index. This loads the real and imaginary parts of the refractive index at every simulation node position from the file index\_file. The index\_file is consisted entirely of pairs of numbers. The number of pairs must be identical to the product of x\_simulation\_nodes, y\_simulation\_nodes and z\_simulation\_nodes. The first number of each pair is the real part of the refractive index and the second number is the imaginary part. The order of the pairs is such that the first pair corresponds to the lower left corner of the simulation domain. Ordering is done by first incrementing along the x-direction, followed by the y-direction, and lastly the z-direction. A file of such format can be generated using the keyword write index.

#### write index index file

keyword write\_index specifies that the real and imaginary parts of the refractive index at every simulation node position to be written to the file *index\_file*. This file can be used as the argument of read\_index for other TEMPEST simulations.

#### dispersive

if the structure contains highly dispersive materials, i.e.,  $n_i > n_r$ , the conventional algorithm is unstable. A special routine must be used by specifying **dispersive** in the input file.

#### 4.1.4 Analysis

# reflected

keyword reflected specifies that the reflected diffraction harmonics are calculated. The diffraction harmonics are computed at discrete scattering angles which depend on the incident wavelength and the dimensions of the simulation domain. These diffraction harmonics can be used by the program SPLAT to generate an optical image profile of the simulated structure.

#### transmitted

keyword transmitted specifies that the transmitted diffraction harmonics are calculated.

#### no de

keyword no\_de specifies that no diffraction harmonics are calculated. This is the default.

# min\_cycle min\_wave\_cycles

Since checking for steady-state slows down the simulation, TEMPEST excites the simulation domain *min\_wave\_cycles* wave cycles before checking

for steady-state. Typically, at least 20 wave cycles of excitation are required before steady-state is reached. The number of wave cycles needed increases with complexity of the topography as well as the z\_length of the simulation domain. If unspecified, the program calculates min\_wave\_cycles automatically.

#### max\_cycle max wave cycles

Simulation continues until steady-state is reached or until the domain has been excited with max\_wave\_cycles wave cycles, whichever comes first. If steady-state is not reached before max\_wave\_cycles wave cycles of excitation, diffraction efficiencies are not calculated. A typical value for max\_wave\_cycles is 100. If unspecified, the program calculates max\_wave\_cycles automatically.

#### err tol fraction

Steady-state is determined by comparing the field values across an xy-plane (set at 5 simulation nodes from the boundary where the diffraction harmonics are taken, if no\_de is specified, the plane is set at 5 simulation nodes from the top boundary) at the same instant in successive wave cycles. If the variation of the electric field at each node on the plane is less than *fraction* times a comparing value (this comparing value is determined by the specification or no specification of the keyword err\_rel) for three consecutive wave cycles, steady-state is reached. A typical value for *fraction* is 0.02, where:

error = fraction x amplitude  
$$|E_{new} - E_{old}| >= error$$

#### err rel

err\_rel specifies that the comparing value is the instantaneous field value. If err\_rel is not specified, the incident field amplitude is used as the comparing value.

#### 4.1.5 Data

plot plot\_var plot\_type [fraction] [plot\_dir] coor [min1 max1 min2 max2 min3
max3] plot\_file

plot\_var must be one of the five keywords: pac, refractive, steady, nonsteady, or transient.

pac requests a PAC concentration plot after the photoresist is exposed.

refractive requests a plot of the real part of the refractive index. This is a check to ensure that the structure is loaded into TEMPEST correctly.

steady requests a plot of the instantaneous values of a field component at steady-state. The field component is specified by plot\_dir and the instant of the wave cycle is specified by fraction.

nonsteady requests a plot of the instantaneous values of a field component before the field reaches steady-state. The field component is specified by plot\_dir, and fraction specifies the number of cycles after the initial excitation at which the field values are taken. Note that instant in this case must be smaller than min\_wave\_cycles specified in min\_cycle.

transient requests a transient plot of a field component specified by plot\_dir. This option traces the time development of the field value of a point in the simulation domain. When transient is specified, plot\_type must be point.

plot\_type must be one of the six keywords: point, xline, yline, zline, xyplane, yzplane, or zxplane.

**point** requests a plot of *plot\_var* at a point in the simulation domain. This *plot type* is usually used when a **transient** plot is requested.

xline requests a line plot of plot\_var at a cutline in the x-direction from min1 to max1 at the position y=min2 and z=min3. max2 and max3 are not specified in this case.

yline requests a line plot of plot\_var at a cutline in the y-direction from min1 to max1 at the position z=min2 and x=min3. max2 and max3 are not specified in this case.

zline requests a line plot of plot\_var at a cutline in the z-direction from min1 to max1 at the position x=min2 and y=min3. max2 and max3 are not specified in this case.

xyplane requests a two-dimensional plot of  $plot\_var$  across an xyplane bounded by  $x=\{minl,maxl\}$  and  $y=\{min2,max2\}$  at the position z=min3. max3 is not specified in this case.

yzplane requests a two-dimensional plot of  $plot\_var$  across an yzplane bounded by  $y=\{minl,maxl\}$  and  $z=\{min2,max2\}$  at the position x=min3. max3 is not specified in this case.

zxplane requests a two-dimensional plot of  $plot\_var$  across an zxplane bounded by  $z=\{minl,maxl\}$  and  $x=\{min2,max2\}$  at the position y=min3. max3 is not specified in this case.

fraction is specified only if a steady or nonsteady plot is desired. If a steady plot is desired, fraction is a number between 0.0 and 1.0 specifying the fraction of the wave cycle at which the plot is generated. A value of 0.0 means the beginning of a wave cycle and a value of 0.25 means a quarter of a wave cycle after the beginning (a phase of 90 degrees). If a nonsteady plot is desired, a plot after

fraction cycles of excitation is generated. Note that for a nonsteady plot, the value of fraction must be a number between 0.0 and min wave cycles.

plot\_dir is specified only if plot\_var is one of steady, nonsteady, or transient. plot\_dir contains two entries. The first entry is either e or h, specifying the electric field or the magnetic field. The second entry can be one of the following: x, y, or z, specifying the direction of the field.

coor can be either of the two keywords position or node. position specifies that the coordinates min1, max1, min2, max2, min3, and max3 are specified in micro-meters. node specifies that min1, max1, min2, max2, min3, and max3 correspond to the simulation node number. The convention is that (0, 0, 0) corresponds to the spatial location (0, 0, 0) and  $(x_simulation_nodes)$ ,

y\_simulation\_nodes, z\_simulation\_nodes) corresponds to (x\_length, y\_length, z\_length).

plot\_file is the name of the file to which data are written. All the data files are in the PLOTMTV format. A maximum of 50 plots can be generated.

#### 4.2 TEMPEST commands

#### 4.2.1 TEMPEST

The program TEMPEST takes two arguments. The first of which is the name of the input file which contains the topography information. The second argument is the name of the output file to which information on the simulation run is written.

cm% tempest input file output file

#### 4.3 Post-TEMPEST Workstation Commands

#### 4.3.1 SPLAT

Based on the information of the diffraction harmonics contained in the output file, the optical image profile of the simulated structure can be synthesized given the characteristics of the optical system including the numerical aperture (NA), partial coherence factor ( $\sigma$ ), and the magnification factor. This is done by the simulation program SPLAT which calculates the aerial images. Since TEMPEST assumes coherent illumination, partial coherence in SPLAT is modeled by Hopkins' approach<sup>1</sup>. Two assumptions are made:

- 1. The magnitudes of the diffraction efficiencies are independent of the angle of illumination.
- 2. The illumination energy is distributed evenly over the illumination cone.

With these assumptions, the intensity at every point in space can be calculated by evaluating the transmission cross coefficients<sup>1</sup>. This approach can be used to model bright-field or dark-field optical systems, arbitrary lens aberrations as well as defocus effects.

For a detailed description of SPLAT, please refer to the SPLAT User's Guide<sup>5</sup>. A typical input file for SPLAT is shown as follows:

```
# hole.spl
#
1: printlevel = 3;
2: lambda = 0.248;
3: NA = 0.500;
31: magnification = 1.000 mode = 1;
4: defocus = 0.000;
5: sigma = 0.500;
6: mask = 0.500um x 0.500 um @0;
37: "hole.hrm ";
10:
11: 0.000 0.000 1.000 1.000 51 51 'hole.spl.i2d';
14: 0.000 0.000 1.000 0.000 201 'hole.spl.i1d';
0:
```

#### 4.3.2 PLOTMTV

PLOTMTV is developed by Kenny Toh at Intel Corporation. It is available in the public domain and is distributed along with TEMPEST. Files in the PLOTMTV format can be plotted using the command:

```
ws% plotmtv [-nodate] [-colorps] [-l] file name
```

where *file\_name* is the name of the data file. If [-nodate] is specified, the postscript file generated by PLOTMTV has not date stamp on it. To generate color postscript files, specify the [-colorps] option. The [-l] option specifies that the graph is plotted in the landscape orientation.

#### 4.3.3 AMPHA1D and AMPHA2D

The amplitudes and phases of the electromagnetic can be calculated from the instantaneous field values using the routines AMPHA1D and AMPHA2D. These two routines take as input two data files corresponding to the instantaneously field values at two instants separated by a quarter of a wave cycle. Two data files are generated which contain respectively the amplitude and phase information.

The synopses of ampha1d and ampha2d are identical. For one-dimensional data files (i.e., data files generated with plot\_type equal to xline, yline, or zline), ampha1d is used. For two-dimensional data files (i.e., data files generated with plot\_type equal to xyplane, yzplane, or zxplane), ampha2d is used.

ws% ampha1d/2d file 000 file 250 file amp file pha

where file\_000 and file\_250 are the input data files. file\_250 contains field values which occur a quarter of a wave cycle later than the data in file\_000. file\_amp and file\_pha contain the amplitude and phase information respectively. The data files file\_000 and file\_250 can be generated using the TEMPEST input keyword plot as described in Section 4.1.5. For an example, please refer to the TEMPEST input file shown in Section 3.2.

#### 4.3.4 FACTOR1D and FACTOR2D

In some cases the user may wish to scale an axis of a plot file in the PLOTMTV format. For example, the user may wish to normalize the optical image profile to a certain level. This is accomplished by the routines FACTOR1D and FACTOR2D.

For line plots, use

ws% factor1d input file output file dir factor

where *input\_file* is the data file in PLOTMTV format and *output\_file* is the name of the file to which the modified data is written. *dir* is either x or y, specifying either the x-axis or the y-axis is scaled by a factor of *factor*.

For two-dimensional plots, use

ws% factor2d input file output file factor

where *input\_file* is the data file in PLOTMTV format and *output\_file* contains the modified data. All the data points are multiplied by a factor of factor.

#### 4.3.5 REDUCE2D

Sometimes the size of the data file is so large that processing is extremely slow and takes up too much disk space. One way to speed up processing and reduce storage memory is by reducing the number of data points with the routine reduce2d as follows:

ws% reduce2d input file output file x factor y factor

In the x-direction, reduce2d takes one datum out of every x factor data from input file. In the y-direction, the program takes one datum out of every y factor data from input file. The reduced data set is written to output file. The size of output file is thus (x factor\* y factor) times smaller than input file. From

#### **Detail Command Descriptions**

experience, taking one datum out of two to four data from a raw TEMPEST data file retains the resolution yet improves processing time and reduces storage memory.

#### 4.3.6 TOTAL1D and TOTAL2D

In some applications the user may wish to have information on the total electric or magnetic field rather than the values of the field components. To calculate the total field from the field component values, TOTAL1D and TOTAL2D, which are applicable for line plots and contour plots respectively, can be used.

ws% total1d/2d x\_component y\_component z\_component total

where x\_component, y\_component, z\_component are PLOTMTV data format files containing the field component values in the x-, y-, and z-directions, and total is the output file name.

#### 4.3.7 DPL2MTV and CTR2MTV

The data files generated by SPLAT are either in the DRAWPLOT (in the case of line plots) or the CONTOUR (in the case of contour plots) format. The routines DPL2MTV and CTR2MTV can be used respectively to convert from the DRAWPLOT format to the PLOTMTV format and from the CONTOUR format to the PLOTMTV format:

ws% dpl2mtv DRAWPLOT\_file PLOTMTV\_file ws% ctr2mtv CONTOUR\_file PLOTMTV file

11	00	fa a l	ш	ints
u	36	u		11112

#### 5.0 Useful Hints

#### 5.1 Top and Bottom of the Simulated Structure

The materials at the top and bottom of the simulated domain must be homogeneous. Also, the entire simulation domain must be filled (material properties specified). It is suggested that the first block of material is defined to be a rectangular box with dimensions conforming to the size of the simulation domain.

# 5.2 Material Interface from the Top and Bottom Boundaries

If a material interface exists very close to the top of the simulation domain, simulation results may be inaccurate. The distance between an interface and the top of the simulation domain should be about one wavelength. This consideration applies to the interface closest to the bottom of the simulation domain as well. Also, material properties must be uniform across the top and bottom boundaries of the simulation domain.

# 5.3 Verification of Loaded Topography

If it is suspected that the loaded topography does not coincide with which the user has in mind, the user can verify the loaded topography by plotting the real part of the refractive index using the keyword plot as described in Section 4.1.5.

# 5.4 Real and Imaginary Parts of the Refractive Index

Numerical instability may occur when the imaginary part of the refractive index of a particular material block is greater than the real part. Such a situation may arise if a metal block is present. In such instances, the line "dispersive" must be included in the input file to TEMPEST.

#### 5.5 Number of Simulation Nodes

The number of simulation nodes needed in order to give accurate simulation results can be determined by the following relation:

x\_simulation\_nodes > (15\*largest\_index\*x\_length)/wavelength

and the number of simulation nodes in the y- and z-directions can be determined from  $x_{simulation\_nodes}$  by the ratios of  $x_{length}$ ,  $y_{length}$  and  $z_{length}$ .

	Useful Hints
5.6	Periodic and Isolated Structures

In the current version, **isolated** structures cannot be analyzed. **periodic** structures must be assumed. Isolated structures can be modeled by using a large periodic simulation domain.

# 5.7 Convergence Problems

If the user encounters convergence problems, it may be due to the presence of a highly dispersive material block. Specify the keyword dispersive may alleviate the problem.

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# Appendix A Summary of Commands

```
ampha1d/2d, routines which calculate the amplitudes and phases from instantaneous field data 33

C ctr2mtv, data conversion program 35

D dpl2mtv, data conversion program 35

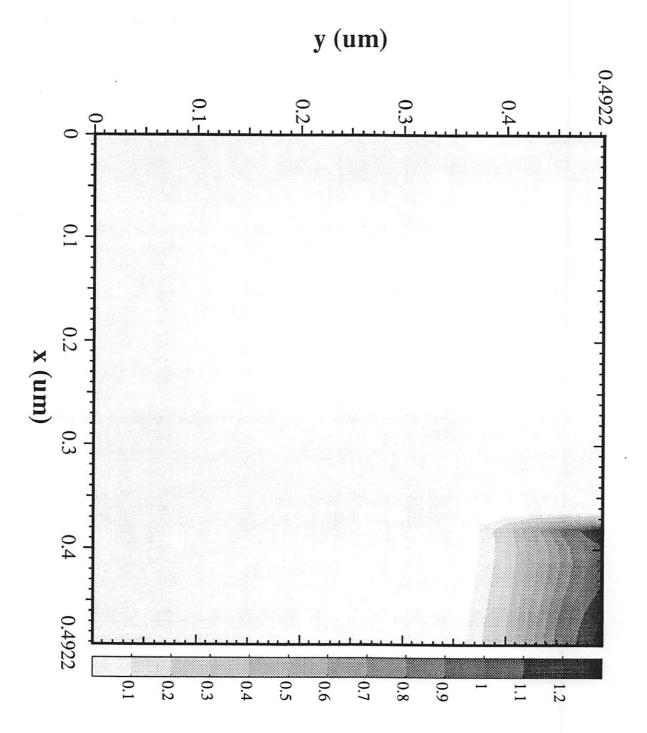
F factor1d/2d, scaling programs for files in PLOTMTV format 34

I image2d, image synthesis routine 32

P plotmtv, plotter 33

R reduce2d, routine which converts large data files to smaller ones by discarding data points 34
```

tempest, electromagnetic fields solver 32 total1d/2d, calculate total field from field components 35



Offending Command = InitDictCount
Error = nametype : undefined
this name is not defined in a dictionary
Stack =

3